

	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/017,261	DAMON ET AL.	
ſ	Examiner	Art Unit	
	CHUONG T. HO	2616	

	SEARCHED				
Class	Subclass	Date	Examiner		
370 370	392× 3895	07/26/06	OH-		
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370	409				
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370	395.3				
709	203				
709	2381				
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INTERFERENCE SEARCHED					
Class	Subclass	Date		Examiner	
370	392	07/2	6/06	, e	사 
370	389				
376	395.31				
709	238				
709	245		,		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
WEST (Text rearch, Class rearch) EAST STN	07/26/06	CH		
IEEE	↓	1		